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06/23/2011

Docket No. F-9089

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RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1795

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Joachim MAI, et al.
 Serial No. : 10/578,047
 Filed : August 7, 2007
 For : METHOD AND DEVICE FOR ION BEAM
 PROCESSING OF SURFACES
 Group Art Unit : 1724
 Examiner : Rodney Glenn McDonald
 Confirmation No. : 5426
 Customer No. : 000028107

Certificate of Facsimile Transmission Under 37 CFR 1.8

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C. Bruce Hamburg
 (Name)

(Signature)

MAIL STOP AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Sir:

In response to the final Office Action of April 20, 2011 entry of the present amendment effecting claim amendments to place the application in condition for

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Docket No. F-9089

Ser. No. 10/578,047

allowance or remove issues from appeal, if required, is respectfully requested. Please
amend the above-identified patent application as follows: